IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kwang Su Choe, et al. Examiner: Marianne L. Padgett

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For: THIN BURIED OXIDES BY LOW-DOSE Dated: February 12, 2008

OXYGEN IMPLANTATION INTO MODIFIED SILICON

Confirmation No: 4796

Mailstop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.116

Sir

In response to the Office Action dated December 21, 2007, please consider the

following amendments and remarks with respect to the above referenced application.

CERTIFICATE OF ELECTRONIC FILING

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I hereby certify that this correspondence is being electronically filed with the United States Patent and Trademark Office e-business website on the date listed below.

Dated: February 12, 2008 Leslie S. Szivos